

TCD3000 SiA TCD3000 Si

TECHNICAL SPECIFICATIONS





General application areas



- Oil & gas Petrochemicals
- Chemicals and plastics
- Gas chromatographs
- Air separators & pure gas production
- Gas leak detection
- Pharmaceutical & food industry
- Metals, minerals, pulp & paper industry
- Power generation
- Environmental technology

Application examples

Hydrogen measurement in electrolysis	O ₂ in H ₂	Upper Explosion Limit (UEL)	
Oxygen measurement in electrolysis	H ₂ in O ₂	Lower Explosion Limit (LEL), with high moisture content	
H₂ contamination in electrolysis, fuel cells, and semiconductor industry	H ₂	99 to 100 vol.%, H ₂ Quality 4.0	
Exhaust gas measurement in fuel cells	H₂ in Air	LEL monitoring with very high water content	
H ₂ injection into the natural gas network	H₂ in Natural Gas	0 to 100 vol.%, mixing control	
Decomposition and synthesis of ammonia	H₂ in N₂ + NH₃	0 to 100 vol.%, process control	
Turbogenerators in power generation	H ₂ in air, H ₂ in CO ₂ (Ar), CO ₂ (Ar) in air	Monitoring of UEL, draining and filling process	
Pure gas production and incoming goods inspection	H ₂ , He, CH ₄ , O ₂ , N ₂ , CO ₂ , Ar	Identification of the quality of produced and delivered gases	
Industrial applications	H ₂ in N ₂	e.g. 0 to 10 vol.%, systems for the production and monitoring of forming gas	
Safety monitoring	H₂ in air	LEL, analysis of hydrogen dispersion in facilities and buildings	



ARCHIGAS



Archigas' measurement method is based on the principle of thermal conductivity (TCD = Thermal Conductivity Detector). This technology is ideal for measuring gases with widely differing thermal conductivities, such as H₂ and O₂.

TCD3000 SiA - H₂ gas analyzer with ATEX certification

The TCD3000 SiA model is designed for hydrogen detection in areas that require ATEX certification. The compact and robust gas analyzer with the specifications II 2 G Ex db IIC T4/T3 Gb, -40°C < Ta < +90°C / 125°C for ATEX ZONE 1 is ideal for the precise, fast, and sensitive measurement of quasi-binary gas mixtures.

TCD3000 Si - H2 gas analyzer

The **TCD3000 Si** variant is suitable for hydrogen detection in **non-hazardous areas.** The compact and robust gas analyzer is ideal for precise, fast, and sensitive measurement of quasibinary gas mixtures.



Advantages

The compact and robust screw-in devices are predestined for the precise, fast, and sensitive measurement of (quasi-)binary gas mixtures. Detection is based on the principle of thermal conductivity. This technology is ideal for measuring gases with widely differing thermal conductivities, such as H_2 and O_2 .

High precision and speed:

The solutions feature an **industry-leading response time of 30 ms** and a **measuring range from a few ppm to 100 vol.%,** specially developed for the new requirements of the hydrogen infrastructure in the energy and process industries.

• Exceptional robustness for demanding environments:

The analyzers deliver precise measurements up to a pressure of 200 bar and more. In addition, depending on the application, they can withstand condensate and water without damage. This makes them ideal for electrolysers, fuel cells, and other hydrogen applications.

Maximum safety, minimal maintenance:

With **fast and reliable explosion level monitoring**, the devices significantly increase workplace safety. They are a long-term investment with an expected **service life of up to 10 years**.

· Adaptability meets cost-effectiveness:

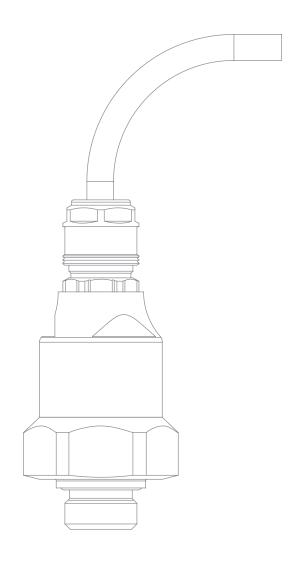
The extremely compact screw-in devices **save space and costs.** Thanks to them, the most diverse gas mixtures can be measured without additional sample preparation – a highly efficient solution that outperforms the competition in terms of performance and price.





Specifications 1/2

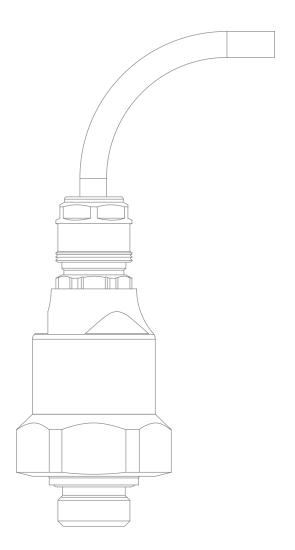
General technical data		
SiA Dimensions with connectors	H: 96 mm; Ø: 45 mm	
SiA Weight	740 g	
Si Dimensions with connectors	H: 91 mm; Ø: 45 mm	
Si Weight	440 g	
Protection class	IP66 / IP68 according to EN 60529	
Installation position	independent	
Gas connection	G 1/2" or NPT 1/2"	
Electrical inputs and outputs		
Power supply	24 ±25 % VDC, < 5 W	
Analogue output	4-20 mA potential-bound, RL \leq 750 Ω	
Serial interface	RS485, baud rate 38400, 8 data bits	
Measuring ranges		
Smallest possible measuring span	0 to 0.5 vol.%	
Largest possible measuring span	0 to 100 vol.%	
Number of measuring ranges	10; freely parameterisable	
Gas inlet conditions		
Sample gas pressure	0.9 to 200 bar (absolute)	
Sample gas flow	0 to 10 m/s (higher flow rates on request)	
Sample gas temperature	-40 to +90 °C / +125 °C	
Sample gas humidity	up to 100 % RH	





Specifications 2/2

Time behaviour	
Warm-up time	< 1 min
Reaction time	≤ 30 ms
T90 time	<1s
Measuring behaviour	
Noise	< 10 ppm
Detection limit	< 50 ppm
Measured value drift	< 100 ppm / week
Repeatability	< 100 ppm
Linearity deviation	< 1 % of the current measuring span
Influencing variables	
Ambient temperature	< 50 ppm / 10 K
Sample gas pressure at zero point	< 25 ppm / 10 hPa; from 1 MPa < 2 ppm / 10 hPa
Sample gas pressure for deflection gas	< 100 ppm / 10 hPa; from 1 MPa < 10 ppm / 10 hPa
Sample gas flow at zero point	< 25 ppm / 10 l/h
Sample gas flow rate with deflection gas	< 100 ppm / 10 l/h
Climatic conditions	
Storage and transport	-40 to +90 °C
Ambient temperature	-40 to +90 °C
Ambient humidity	up to 100 % RH
Parts in contact with sample gas	
Screw-in housing	Stainless steel 316L
Sintered metal filter	Stainless steel 316L
Sensor	Si, SixNy, potting compound, ceramics
Gasket	FKM, optional: FFKM or PTFE

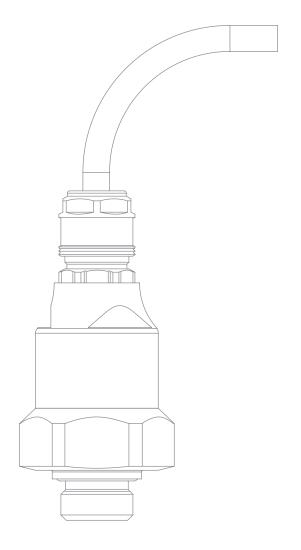


All data refer to the measuring range 0.5 vol.% H_2 in N_2



Most requested measurement components and ranges

Measuring gas	Carrier gas	Basis range	Smallest range
Hydrogen (H ₂)	Oxygen (O ₂)	0 to 100 vol.% *	0 to 0.5 vol.%
Oxygen (O ₂)	Hydrogen (H ₂)	0 to 100 vol.% *	0 to 1.0 vol.%
Hydrogen (H₂)	Nitrogen (N ₂) or air	0 to 100 vol.%	0 to 0.5 vol.%
Nitrogen (N ₂)	Hydrogen (H ₂)	0 to 100 vol.%	0 to 2.0 vol.%
Hydrogen (H ₂)	Argon (Ar)	0 to 100 vol.%	0 to 0.5 vol.%
Hydrogen (H₂)	Helium (He)	20 to 100 vol.%	-
Hydrogen (H₂)	Methane (CH ₄)	0 to 100 vol.%	0 to 0.5 vol.%
Hydrogen (H ₂)	Carbon dioxide (CO ₂)	0 to 100 vol.%	0 to 0.5 vol.%
Helium (He)	Nitrogen (N ₂) or air	0 to 100 vol.%	0 to 0.8 vol.%
Helium (He)	Argon (Ar)	0 to 100 vol.%	0 to 0.5 vol.%
Methane (CH ₄)	Nitrogen (N ₂) or air	0 to 100 vol.%	0 to 2.0 vol.%
Methane (CH ₄)	Argon (Ar)	0 to 100 vol.%	0 to 1.5 vol.%
Oxygen (O ₂)	Hydrogen (H ₂)	0 to 100 vol.%	0 to 15.0 vol.%
Oxygen (O ₂)	Argon (Ar)	0 to 100 vol.%	0 to 2.0 vol.%
Oxygen (O ₂)	Nitrogen (N ₂)	0 to 100 vol.%	0 to 3.0 vol.%
Nitrogen (N ₂)	Argon (Ar)	0 to 100 vol.%	0 to 3.0 vol.%
Carbon dioxide (CO ₂)	Nitrogen (N ₂) or air	0 to 100 vol.%	0 to 3.0 vol.%
Carbon dioxide (CO ₂)	Argon (Ar)	0 to 60 vol.%	0 to 10.0 vol.%
Argon (Ar)	Carbon dioxide (CO ₂)	40 to 100 vol.%	_
Argon (Ar)	Oxygen (O ₂)	0 to 100 vol.%	0 to 3.0 vol.%



TCD technology also allows to perform the measurements of the following industrial gases: SF₆, NO₂, Neon, Krypton, Xenon, Deuterium etc.

^{*} correspondent safety measures must be taken by the client in the application with explosive gas mixtures



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